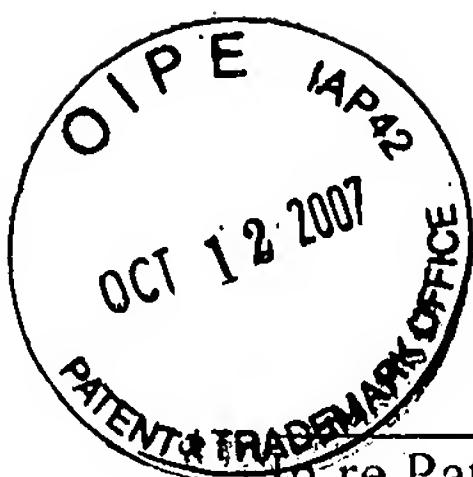


I Pm



Docket No.: 0630-2627PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Young-Man JEONG et al.

Application No.: 10/565,107

Confirmation No.: 5526

Filed: March 5, 2007

Art Unit: 1763

For: PLASMA SURFACE PROCESSING SYSTEM
AND SUPPLY DEVICE FOR PLASMA
PROCESSING SOLUTION THEREFOR

Examiner: Not Yet Assigned

LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the Notification of Acceptance mailed July 23, 2007 in connection with the above-identified application, enclosed herewith are copies of the documents that were cited in the International Search Report and listed on the attached Form PTO-SB08 filed with the Information Disclosure Statement on January 19, 2006.

The PTO is requested to make these documents of record in the file of the present application and to return the enclosed initialed Form PTO-SB08 to the undersigned.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to our Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Dated: October 12, 2007

Respectfully submitted,

By Esther Chong
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Attachments: Documents cited in Search Report (2)

PTO Form SB08 (copy from previously filed IDS)